



1763
[Signature]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kouji TOMETSUKA Confirmation No: 5599
Appl. No. : 09/911,741
Filed : July 25, 2001
Title : SUBSTRATE PROCESSING APPARATUS AND METHOD

TC/A.U. : 1763
Examiner : R.N. KACKAR

Docket No.: : TOME3001/REF
Customer No: : 23364

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants request that the period for response to the outstanding official action in this case be extended pursuant to 37 CFR 1.136 (a) for TWO (2) months to August 12, 2004.

The fee set in 37 CFR 1.17(a)(2) for a two month extension of time is \$420.00 and a check in this amount is submitted herewith. Please charge any additional fee required for this extension to Deposit Account No. 02-0200. A duplicate copy of this paper is attached.

Respectfully submitted,

BACON & THOMAS, PLLC

08/12/2004 EABUBAK1 00000016 09911741

01 FC:1252

420.00 OP

By: *Richard E. Fichter*
Richard E. Fichter
Registration No. 26,382

625 Slaters Lane, 4th Fl.
Alexandria, Virginia 22314
Phone: (703) 683-0500
Facsimile: (703) 683-1080

REF:kdd
EXT-LRG.2EX.wpd

August 10, 2004